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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yoshihito OOKAWA et al.

Serial No.: New

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Examiner: To Be Assigned

For : PLASMA PROCESSING UNIT, WINDOW MEMBER FOR PLASMA PROCESSING
UNIT AND ELECTRODE PLATE FOR PLASMA PROCESSING UNIT

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

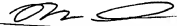
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents cited in the Written Opinion and the International Search Report accompanying the national stage documents being filed on this same date together with a copy of each reference cited therein.

It is respectfully requested that each cited document be considered by the Examiner in the above-identified patent application and that each cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed within three months of the filing date of the present application, and therefore it is believed that no fees are due under 37 C.F.R. Section 1.97(j).

Respectfully submitted,
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